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PATENT APPLICATION

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

YUKIKO IWASAKI ET AL.

Application No.: 10/083,585

Filed: February 27, 2002

For: METHOD FOR  
MANUFACTURING A  
SEMICONDUCTOR FILM

Examiner: N/Y/A

Group Art Unit: N/Y/A

May 14, 2002

Commissioner for Patents  
Washington, D.C. 20231

RESPONSE TO NOTICE OF OMITTED ITEMS  
AND PRELIMINARY AMENDMENT

Sir:

In response to the Notice of Omitted Items mailed March 19, 2002, and prior to issuance of an Office Action, please amend the above-identified application as follows.

IN THE SPECIFICATION

Replace the specification currently on file with the Substitute Specification submitted herewith. (A version of the Substitute Specification marked up to show the changes is also submitted.)